

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)			Docket Number (Optional) YOR9-2000-0186US1		Application Number 09/556,952 Not Yet Assigned		U.S. PTO 09/556952 04/21/00
			Applicant Breen et al.				
			Filing Date April 20, 2000		Group Art Unit 1734 Not Yet Assigned		

U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	4,916,115	4/10/90	Mantese et al.	505	1		
	4,952,556	8/28/90	Mantese et al.	505	1		
	5,512,131	4/30/96	Kumar et al.	156	655.1		
	5,620,850	4/15/97	Bamdad et al.	530	300		
	5,900,160	5/4/99	Whitesides et al.	216	41		
	6,020,047	2/1/00	Everhart	428	209		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)	
	<i>Organic-Inorganic heterostructure electroluminescent device using a layered perovskite semiconductor (C₆H₅C₂H₄NH₃)₂Pbl₄</i> , Era et al. in Appl. Phys Lett. 65 (6), 8 August '94 pp.676-678
	<i>Manipulation of the Wettability of Surfaces on the 0.1- to 1-Micrometer Scale through Micromachining and Molecular Self-Asembly</i> by Abbott et al., in Science, Vol. 257, 4 Sept. 1992, pp. 1380-1382
	<i>Maskless photolithography: Embossed photoresist as its own optical element</i> by Paul et al., in Applied Physics Letters, Vol. 73, No. 20, 16 Nov. 1998, pp. 2893-2895
	<i>Patterning of dielectric oxide thin layers by microcontact printing of self-assembled monolayers</i> by Jeon et al. in J. Mater. Res., Vol. 10, No. 12, dec 1995, pp. 2996-2999.

EXAMINER	DATE CONSIDERED 2/28/2001
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.